

Application/Control No.	Applicant(s)/Patent	Applicant(s)/Patent under Reexamination	
09/242,772	VAN DE VEN ET	VAN DE VEN ET AL.	
Examiner	Art Unit		
Young J. Kim	1637		

SEARCHED					
Class	Subclass	Date	Examiner		
,					
			-		
			-		
· · · · · · · · · · · · · · · · · · ·					

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
SEQ ID NO: 116 - interference database via STIC.	12/19/2005	ΥЈК		